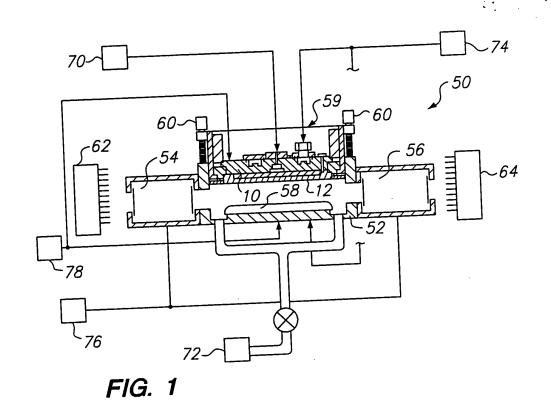
APPLN. FILING DATE: DECEMBER 29, 2000
TITLE: ELECTRODE FOR PLASMA PROCESSES ...
ENTOR(S): JEROME S. HUBACEK ET
ENTOR(S): JEROME S. HUBACEK ET
SHEET 1 of 3
APPLICATION SERIAL NO: 09/749,916



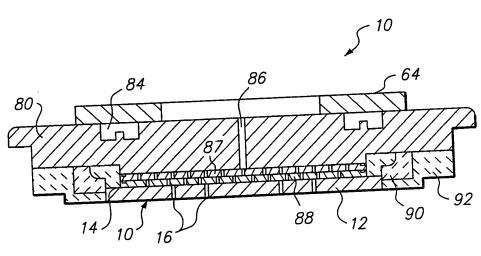


FIG. 2

APPLN. FILING DATE: DECEMBER 29, 2000
TITLE: ELECTRODE FOR PLASMA PROCESSES ...
INTO TOR(S): JEROME S. HUBACEK ET A
APPLICATION SERIAL NO: 09/749,916
SHEET 2

SHEET 2 of 3

*152*. 152 136, 132 146 <u>155</u> 143 - 132B 144 -143 -134 132a 140 130 138 142 154

FIG. 3

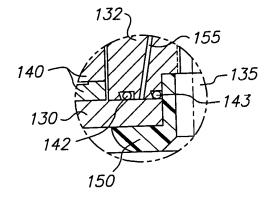


FIG. 4

TITLE: ELECTRODE FOR PLASMA PROCESSES ...
IN TOR(s): JEROME S. HUBACEK ET A
APLICATION SERIAL NO: 09/749,916 HEET 3 of 3

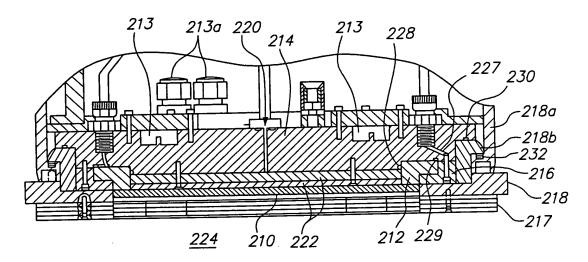


FIG. 5

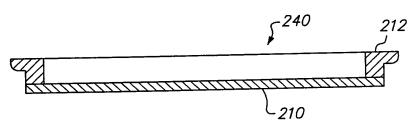


FIG. 6

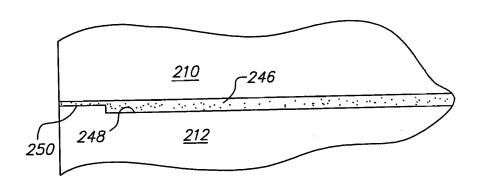


FIG. 7